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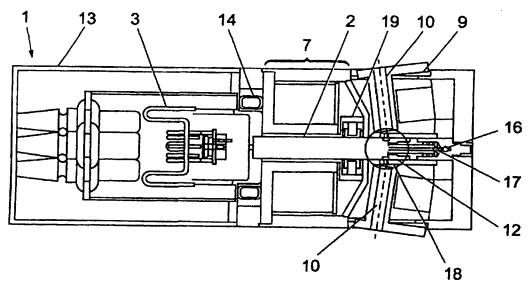
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(54) Title: X-RAY GENERATOR



(57) Abstract

An X-ray generator comprises an evacuated and sealed X-ray tube, an electron gun, an X-ray target, an internal electron mask, and an X-ray window consisting of a thin tube of material with low X-ray absorption and high mechanical strength, for example beryllium. The window connects the tube to the target assembly containing the X-ray target. The generator preferably also includes a system for focusing and steering the electron beam onto the target, a cooling system to cool the target material, kinematic mounts to allow precise and repeatable mounting of X-ray devices for focusing the X-ray beam, and X-ray focusing devices of varying configurations and methods. The X-ray generator of the invention produces an X-ray source having a focal spot or line of very small dimensions and is capable of producing a high intensity X-ray beam at a relatively small point of application using a low operating power.

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1 X-Ray Generator 2 This invention relates to an X-ray generator and in 3 particular to an X-ray generator suitable to be closely coupled to a focusing X-ray device. 5 7 X-ray generators comprise an electron gun, an X-ray target and an X-ray exit window, generally in a sealed 8 vacuum. Prior art generators produce X-ray beams 9 having a relatively large focal spot or line. Many 10 applications require a precisely collimated X-ray beam. 11 To achieve this relatively small apertures are coupled 12 13 with the generator to restrict beam diameter and divergence, but this results in a large loss of X-ray 14 15 intensity. 16 17 For many applications the most effective way of using the X-rays emitted from the target of an X-ray tube is 18 19 to form an image of the source, i.e. of the electron 20 focus on the target, on the specimen. crystallographic applications, it is normally essential 21 22 that the convergence or divergence of the rays incident 23 on the sample be very small. To maximise the X-ray 24 intensity at the sample the angle of collection at the 25 source should be as large as possible. The combination

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of these two requirements implies that the imaging 1 2 optics should magnify. The sample size determines the maximum useful image size (see Fig. 3). Fig. 3 shows 3 that the ratio of the collecting angle α at the source 4 S to the beam convergence angle β at the image I is 5 equal to the magnification of the focusing collimator 7 or focusing mirror F. In single-crystal diffractometry, for example, the specimen crystal is 8 frequently about 300 μm in diameter. The X-ray source 9 10 should, therefore, be much smaller than 300 μm . 11 Maximum power loading of the target, without damage to 12 its surface is greatest when the source is a line focus 13 at a small take-off angle to give a foreshortening of 14 15 about 10 times. 16 17 It is an object of the present invention to provide an 18 X-ray generator which produces an X-ray source having a 19 focal spot or line of very small dimensions. further object of the present invention to provide an 20 X-ray generator capable of producing a high intensity 21 X-ray beam at a relatively small point of application 22 23 using a low operating power. 24 According to a first aspect of the invention there is provided an X-ray generator comprising an electron gun, electron focusing means and a target, the electron

25 26 27 28 focusing means being arranged such that the X-ray 29 source on said target may be varied in size and/or 30 shape and/or position.

32 Preferably the X-ray source on said target may be varied from a small diameter spot to a line of small 33 34 width.

36 Preferably the generator further comprises an X-ray

1 exit window comprising a tube of material with low X-2 ray absorption and of a small diameter to allow close 3 coupling of X-ray focusing devices. Preferably the electron focusing means comprises an 5 electron beam focusing means mounted around the X-ray 6 7 The electron beam focusing means may comprise an x-y deflection system for centring the electron beam in 8 the X-ray tube. The electron beam focusing means may 9 further comprise at least one electron lens, preferably 10 an axially symmetric or round lens, and at least one 11 12 quadrupole or multipole lens for focusing the electron 13 beam to a line focus. The line focus preferably has an 14 aspect ratio in the range 1:1 to 1:20. 15 16 The electron beam lenses may be magnetic or 17 electrostatic and are preferably electronically 18 controlled. 19 20 Preferably the material of the exit window has a high 21 mechanical strength and is preferably beryllium. 22 exit window may form part of the mechanical structure 23 of the X-ray tube and preferably connects the X-ray 24 tube and the target. 25 Preferably the target is metal, most preferably a metal 26 selected from the group Cu, Ag, Mo, Rh, Al, Ti, Cr, Co, 27 28 Fe, W, Au. In a preferred embodiment the target is 29 copper. The target surface may be orientated such that the plane of the target surface is perpendicular or at 30 31 an angle to the axis of the X-ray tube. 33

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The target may comprise a thin metal layer deposited on a thicker substrate of a material with high thermal conductivity. Preferably the substrate material is diamond.

1 Preferably the generator further comprises a target 2 cooling means. According to a first embodiment the cooling means may comprise means for directing a jet of 3 4 fluid onto the target, on the opposite side of the target to the side on which the electron beam impinges. 5 6 The fluid is preferably air or water. According to a 7 second embodiment the cooling means may comprise means 8 for effecting heat transfer by conduction or convection 9 from the target. 10 11 Preferably the generator further comprises a deflection 12 means which spatially scans the position of the 13 electron beam over the face of the target. 14 15 Preferably the generator further comprises an electron 16 mask having an aperture adapted to align the focal spot 17 of the electron beam. 18 According to a second aspect of the invention there is 19 20 provided an X-ray generator comprising an electron qun, 21 an X-ray tube, a target and an X-ray exit window 22 comprising a tube of material with low X-ray absorption 23 and of small diameter to allow close coupling of X-ray 24 focusing devices. 26 According to a third aspect of the invention the 27 generator according to the first or second aspects is

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coupled with an X-ray focusing means. The X-ray focusing means preferably comprises a mirror.

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The X-ray source according to the invention is designed specifically to be closely coupled to focusing X-ray devices. It is able to produce a focal spot or line of very small dimensions, and thus maximise the benefit of the focusing methods.

The distance from the electron focus to the exit window 1 exterior is very small, and can be as low as 7 mm or 2 less for a reflection target, or less than 1 mm for a 3 foil transmission target. 4 5 6 The X-ray generator according to the invention is 7 compact and provides a sealed tube. В 9 The X-ray generator according to the invention needs only low power because of the efficiency of the 10 collection and subsequent delivery of X-rays to the 11 12 sample. 13 14 The generator achieves a high brilliance, defined as X-15 ray power per unit area per steradian. 16 17 An embodiment of the invention will now be described, by way of example only, with reference to the 18 19 accompanying figures, where: 20 21 Fig. 1 shows a longitudinal section through an X-ray 22 generator according to the invention; 23 24 Fig. 2 shows a detail to an enlarged scale of part of 25 the X-ray generator shown in Fig. 1; 26 27 Fig. 3 shows the relationship between the size of an X-28 ray source and the image at a sample; and 29 30 Fig. 4 shows the variation in X-ray intensity as an 31 electron beam is scanned across an aperture in front of 32 a target. 33 34 With reference to Figs. 1 and 2, the X-ray generator 1 35 comprises an evacuated and sealed X-ray tube 2, 36 containing the following elements:

	U
1	- Electron gun 3
2	- X-ray target 4
3	- Internal electron mask 5
4	 X-ray window 6 consisting of a thin tube of
5	material with low X-ray absorption and high
6	mechanical strength, for example beryllium.
7	This window also connects the tube 2 to the
8	target assembly 12 containing the target 4.
9	
10	The tube 2 is contained within a housing 13. The
11	generator 1 also includes a system 7 for focusing and
12	steering the electron beam onto the target, a cooling
13	system 8 to cool the target material, kinematic mounts
14	9 to allow precise and repeatable mounting of X-ray
15	devices for focusing the X-ray beam, and X-ray focusing
16	devices 10 of varying configurations and methods. X-
17	ray mirrors 10 are supplied in pre-aligned units so
18	that re-alignment is not necessary after exchange.
19	•
20	The X-ray tube 2 produces a well focused beam of
21	electrons impinging on a target material 4. The
22	electron beam may be focused into a spot or a line, and
23	the dimensions of the spot and line as well as its
24	position may be changed electronically. A spot focus
25	having a diameter falling in the range 1 to 100 μm ,
26	generally 5 μ m or larger, may be achieved.
27	Alternatively a line focus may be achieved whose width
28	falls in a similar range, having a length to width
29	ratio of up to 20:1.
30	
31	An electron beam mask of 5 of metal (eg tungsten) in
32	the form of an internal electron beam aperture 11, with
33	suitable dimensions, for example a rectangular slot for
34	the line focus, may be used with suitable feedback and
35	control mechanisms to automatically align the focal

spot and to maintain its position on the target, for

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example by scanning the electron beam over the aperture 1 2 11 and measuring the emerging X-ray intensity. 3 The electron beam is produced by an electron gun 3, 4 consisting of a Wehnelt electrode and cathode. 6 cathode may be either: 7 a filament of tungsten or alloy, for example 8 tungsten-rhenium, having either a hairpin or a 9 staple shape; or 10 an indirectly heated activated dispenser cathode, which may be flat or of other geometry, for 11 12 example a rod with a domed end. 13 The dispenser cathode has the advantage of extended 14 lifetime and increased mechanical strength. With a 15 flat surface the dispenser cathode has the further advantage of requiring only an approximate degree of 16 17 alignment in the Wehnelt electrode. 18 19 Primary focus is achieved by an anode at a suitable 20 distance from the electron gun. 21 22 A thin tube of material with low X-ray absorption but 23 high mechanical strength and stability, such as 24 beryllium, is used to form the exit window 6 for the 25 emerging X-rays. The tube must exhibit good vacuum 26 seal characteristics. This tube also forms the 27 mechanical connection between the X-ray tube 2 and the 28 target assembly 12. Such an arrangement saves space 29 and complexity in the formation of X-ray windows. 30 31 The electron beam from the gun is centred in the X-ray 32 tube 2 by a centring coil 14 or set of quadrupole 33 Alternatively it may be centred by multipole 34

The electron beam is focused to a spot of

varying diameter. Focusing down to a diameter of less

than 5 μm or better may be achieved by an axial lens 7

consisting of either quadrupole, multipole or solenoid 1 2 type. 3 The spot focus may be changed to a line focus with a 4 further set of quadrupole or multipole lenses. 5 with an aspect ratio of greater than 10:1 are possible. 6 7 A line focus spreads the load on the target. When viewed at a suitable angle, the line appears as a spot. 8 9 10 Lenses are preferably magnetic, but may be electrostatic. All the lenses are electronically 11 controlled, enabling automatic and continuous alignment 12 and scanning of the focal spot. Change from spot to 13 line is also automatic, as is the change of beam 14 15 diameter. 16 17 The target 4 is a metal, for example Cu, but it can be 18 another material depending on the wavelength of the characteristic radiation required, for example Ag, Mo, 19 Al, Ti, Rh, Cr, Co, Fe, W or Au. The target 4 is 20 21 either perpendicular to the impinging electron beam, or 22 may be inclined to decrease the absorption of the 23 emitted X-rays. 24 25 The target is cooled either by: 26 a jet of cooling fluid (water, air or another fluid) directed onto the rear surface of the 27 28 target area by cooling nozzle 15; or conducted or convected heat transfer from the rear of the target 4. The cooling fluid is circulated through an inlet 16 and outlet 17.

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An increase in cooling efficiency (and hence an 35

increase in the permissible target loading) may be 36

1	achieved by the use of a thin metal film of target
2	material deposited on a thicker substrate made from a
3	material with a high thermal conductivity (eg diamond).
4	The target could comprise a thin solid of a single
5	material or it could be laminated with a different
6	material of high thermal conductivity. These targets
7	may be used with different cooling geometries, for
8	example those employing high or low water pressure or
9	forced or natural convection.
10	
11	Both foil transmission and reflection targets may be
12	used as a target 4.
13	
14	Integrated mechanical shutters 18 are positioned
15	between the window 6 and the X-ray focusing elements
16	10, to block the emerging X-ray beam.
17	
18	The placement of the shutter 18 before the focusing
19	elements 10 protects the surface of the mirror from
20	extended radiation damage.
21	
22	A compact X-ray detector may be included to monitor and
23	continuously optimise the position of the electron
24	focal spot. This may be a small solid state detector
25	or other X-ray detecting device.
26	
27	The system encompasses an X-ray focusing device 10
28	located close to the source to provide a magnified
29	image of the focal spot at controlled varying distances
30	from the source. Options for the X-ray focusing
31	systems are:
32	Micromirrors: use specular reflectivity from a
33	gold or similar coating of highly controlled
34	smoothness (around 10 Å rms), from a circularly
35	symmetric profile.
36	 Ellipsoidal profile: gives focused beam of X-

1	rays (currently 300 $\mu \mathrm{m}$ diameter 600 mm from
2	focal spot). Measured insertion gain of >
3	150 (could be 250+). Reason for close
4	coupling is so that a large solid angle of
5	radiation may be collected, but also focusing
6	element forms a magnified image of the focal
7	spot at the sample (low beam divergence but
8	high insertion gain)
9	 Paraboloidal profile: gives a nearly parallel
10	beam (expected gains around 200+)
11	, , ,
12	2 Kirkpatrik-Baez type:
13	 Bent plates arranged in combinations of
14	elliptical or parabolic or combination
15	- Allows simple change of mirror profiles to
16	suit different applications
17	
18	<pre>3 Other possibilities:</pre>
19	- Zone plates
20	 Bragg Fresnel optics
21 .	- Multilayer optics
22	
23	The distance x between the focusing mirror 10 and the
24	source on the target 4 is small, usually lerss than 20
25	mm, preferably about 11 mm, to ensure close coupling.
26	
27	<u>Example</u>
28	
29	A number of copper-target X-ray tubes with focusing
30	collimators were constructed to the same basic
31	specifications shown in the table below.
32	
33	Table of Specifications
34	
35	X-ray tube target Copper, cooled by water or
36	forced air

1 2	Source size	15 μm x 150 μm viewed at 6°
3	Present tube current	0.2 mA at 30 kV
5	X-ray focusing	Ellipsoidal mirror, gold
6	-	surface
7		
8	Source-to-mirror	11 mm
9	distance	
10		
11	Solid angle of	$8.0 \times 10^{-4} \text{ sterad}$
12	collection	
13		
14	Beam convergence	10-3 rad
15	at sample	
16		
17	The cathode is at negative	
18		a filament just inside the
19		id which is biased negatively
20	with respect to the filar	
21 22	accelerated towards the a	_
23		gh a hole in the latter and
23		(tube 2) towards the copper
25		coss-over is formed between the
26	target by the iron-cored	res and this is imaged on the
27		The best electron focus is
28		asses very accurately along the
29		o sets of beam deflection
30		con-cored, are employed in two
31		, mounted between the anode of
32		e axial solenoid 7 to centre
33		lenoid 7 and the target 4 is
34	an air-cored quadrupole m	
35	stigmator 19 in that it t	,
36	section of the beam into	

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1 quadrupole 19 can be rotated about the tube axis so as 2 to adjust the orientation of the line focus. can be moved about on the target surface 4 by 3 4 controlling the currents in the four coils of the 5 quadrupole 19. 6 7 For a tube power below 2 watts the foil target is 8 adequately cooled by radiation alone, but at higher 9 powers forced-air or water-cooling is necessary. 10 tube may be operated continuously at 6 watts but the 11 maximum power compatible with low damage to the target 12 surface 4 is still to be established. 13 14 Computer simulations show that the loading limit of a 15 water-cooled copper target and a focus of 15 μm x 300 16 μm is about 20 watts. Experiments suggest that this 17 figure can be somewhat improved upon by increasing the 18 turbulence in the flow of the coolant. Another 19 approach is to sandwich a layer of a material with a 20 very high thermal conductivity between a very thin 21 copper target layer and a cooled copper block. The 22 sandwiched layer may be a Type II diamond layer, and may be sandwiched between a 5 μm thick copper target 23 24 layer and a water-cooled copper block. Diamond has a 25 thermal conductivity which is up to four times that of 26 copper and our calculations show that its use should 27 allow the permissible power dissipation to be 28 approximately doubled. 29 30 The electron source of a micro-focus X-ray tube must 31 have a high brightness to produce gun currents of the 32 order of 1 mA. 33 34 An indirectly heated cathode a Few hundred micrometers 35 in diameter may be used. The beam cross-section 36 remains circular until the beam reaches the stigmator

and respond was substantial

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1 quadrupole while it can be drawn out into a line 2 between 10 μm and 30 μm in width and with a length-towidth ratio up to 20:1. Such an electron source 3 consumes a much lower filament power than the hair-pin 4 5 tungsten filaments customary for low-power applications; since it operates at a lower temperature, 6 7 it can have a life of several thousand hours. 8 The tube is run in a saturated condition in which the 9 10 current is virtually independent of the filament temperature but is determined by the bias voltage 11 12 between filament and Wehnelt electrode. 13 voltage is the potential drop produced by the tube 14 current flowing through a high resistor; this form of autobias produces a very stable tube current which is 15 16 readily controlled by varying the bias resistance. 17 18 The electron-optical performance of the tubes has been 19 investigated by fitting some of them with 20 μm thick transmission targets. This allowed pinhole photographs 20 21 of the focus to be made. A quick way of assessing the 22 focus was to view the magnified shadow cast by a 200-23 or 400-mesh grid. The electron beam could also be 24 scanned across a rectangular aperture immediately in 25 front to the target. The results are shown in Fig. 4, 26 which shows how the X-ray intensity varies as the 27 electron beam is scanned across the aperture in front 28 of the target. It can be seen that the intensity 29 reaches a peak of about 4000 cps over a range of 30 distance between 60 and 220 micrometres. 31 32 The insertion gain of ellipsoidal mirrors was measured. 33 This gain was defined as the ratio of CuKo X-ray flux 34 into the 0.3 mm diameter image of the X-ray source 35 formed at a distance of 600 mm from the source to the 36 flux into the same area without the mirror. Under

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these conditions the cross-fire at the sample position 1 2 is about 1 milliradian. For the best mirrors the 3 insertion gain was 110. 4 5 The X-ray intensity obtained as above was also compared 6 with that obtained at the focus of a standard double Franks mirror arrangement used with an Elliot GX-21 7 8 rotating anode X-ray generator operated at 2kW. is a conventional combination of X-ray tube and 9 collimator for protein crystallography). When the tube 10 according to the invention was operated at below 1 11 watt, the intensity was only 25 times less than that 12 from the rotating-anode operated at a power 2000 times 13 14 greater. Further improvements are possible, both in X-15 ray tube power and in mirror performance. It should be noted that the insertion gain calculated simply on the 16 17 basis of solid angles of the cone of radiation collected from the source and on the highest values of 18 19 X-ray reflectivity which have been measured is 20 approximately five times greater than that achieved so 21 far. 22 23 These and other modifications and improvements can be 24 incorporated without departing from the scope of the 25 invention.

CLAIMS

1 2

1. X-ray generator comprising an electron gun, an Xray tube, electron focusing means and a target
adapted to have an X-ray source formed thereon,
the electron focusing means being arranged such
that the X-ray source on the target may be varied
in size and/or shape and/or position.

9

X-ray generator according to Claim 1, wherein the
 X-ray source on said target may be varied from a
 small diameter spot to a line of small width.

13

3. X-ray generator according to Claim 1 or 2, further comprising an X-ray exit window comprising a tube of material with low X-ray absorption and of a small diameter to allow close coupling of X-ray focusing devices.

19

20 4. X-ray generator according to Claim 3, wherein the 21 material of the exit window has a high mechanical 22 strength and is preferably beryllium.

23

X-ray generator according to Claim 3 or 4, wherein
 the exit window connects the X-ray tube and the
 target.

27

28 6. X-ray generator according to any preceding Claim,
29 wherein the electron focusing means comprises an
30 x-y deflection system for centring the electron
31 beam in the X-ray tube.

32

X-ray generator according to Claim 6, wherein the
 electron beam focusing means further comprises at
 least one electron lens, preferably an axially
 symmetric or round lens, and at least one

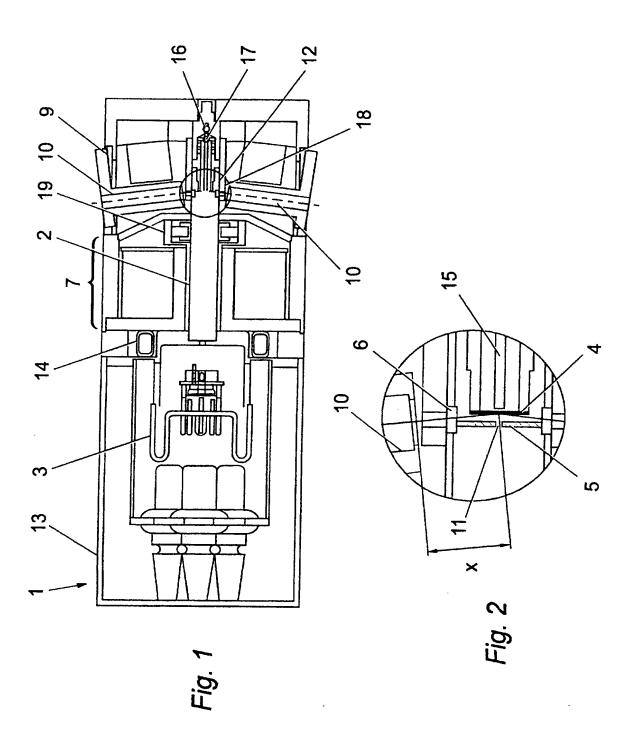
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		16
1		quadrupole or multipole lens for focusing the
2		electron beam to a line focus.
3		
4	8.	X-ray generator according to any preceding Claim,
5		wherein the target is a metal foil transmission
6		target, the metal being selected from the group
7		Cu, Ag, Mo, Rh, Al, Ti, Cr, Co, Fe, W, and Au.
8		
9	9.	X-ray generator according to any preceding Claim,
10		wherein the surface of the target impinged upon by
11		the electron beam is orientated such that the
12		plane of the target surface is perpendicular or at
13		an angle to the axis of the X-ray tube.
14		
15	10.	1 5 the day of any proceeding Claim,
16		wherein the target comprises a thin metal layer
17		deposited on a thicker substrate of a material
18		with high thermal conductivity, preferably
19		diamond.
20		
21	11.	1 5 Proceeding Claim,
22		wherein the generator further comprises a target
23		cooling means.
24		
25	12.	1 5 The later of the proceeding Claim,
26		further comprising an electron mask having an
27		aperture adapted to align the focal spot of the
28		electron beam.
29	• •	
30	13.	X-ray generator comprising an electron gun, an X-
31		ray tube, a target and an X-ray exit window
32		comprising a tube of material with low X-ray
33		absorption and of small diameter to allow close

36 14. X-ray generator according to any preceding Claim,

coupling of X-ray focusing devices.

1		further comprising an X-ray focusing means coupled
2		closely to said target.
3		
4	15.	X-ray generator according to Claim 14, wherein the
5		X-ray focusing means comprises an X-ray mirror
6		whose longitudinal alignment axis is arranged at
7		an angle to the axis of the X-ray tube.
8		
9	16.	X-ray generator according to Claim 15, wherein the
10		angle is between 80° and 90°, preferably about
11		84°.



SUBSTITUTE SHEET (RULE 26)

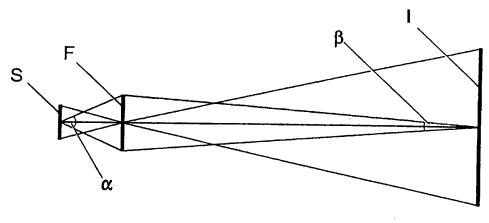


Fig. 3

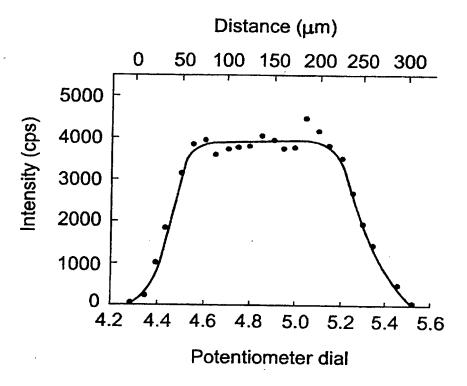


Fig. 4

SUBSTITUTE SHEET (RULE 26)

INTERNATIONAL SEARCH REPORT

In. atlonal Application No PCT/GB 97/02580

A CLASS	SIEICATION OF CUR IFOT MATTER		
IPC 6	H01J35/14		
According	to International Palent Classification(IPC) or to both national class	ification and IPC	
B. FIELDS	SEARCHED		
Minimum of IPC 6	locumentation searched (classification system tollowed by classific ${ t H01J}$	ation symbols)	
	ation searched other than minimum documentation to the extent the		
Electionic	data base consulted during the international search (name of data	base and, where practical, search terms used	.
C. DOCUM	ENTS CONSIDERED TO BE RELEVANT		
Category	Citation of document, with indication, where appropriate, of the r	elevant passages	Relevant to claim No.
X	US 3 732 426 A (SHIMIZU T) 8 Mag see figures		1-5,9,13
Y	see column 1, line 50 - column ;	2, line 43	6-8,10, 11,14-16
Y	US 4 827 494 A (KOENIGSBERG WILL May 1989 see figure 1 see column 3, line 39 - line 55	_IAM D) 2	6,7
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	Tel. (+31-70) 340-2040. Tx. 31 651 epo nl, Fax: (+31-70) 340-3016	Colvin, G	

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